

Docket No.: 0649-0901P  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Takeshi MISAWA

Application No.: 10/620,461

Confirmation No.: 009184

Filed: July 17, 2003

Art Unit: 2811

For: SEMICONDUCTOR DEVICE AND  
METHOD FOR MANUFACTURING THE  
SAME

Examiner: T. F. Tran

**AMENDMENT AFTER FINAL ACTION UNDER 37 C.F.R. 1.116**

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated November 30, 2006, please amend the above-identified U.S. patent application as follows:

**Amendments to the Title** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.